**Two-dimensional materials and applications** 

# 8. van der Waals Heterostructures



### van der Waals Heterostructures



Ultrathin devices for flexible & transparent Ultrasharp heterointerface formed through vdW force

## **Stacking Technique for 2D Heterostructures**



<u>G.H. Lee</u>, J. Hone et al. ACS Nano (2013). APL Materials (2014)

## **Stacking Technique for 2D Heterostructures**

#### Robotic assembly of artificial nanomaterials



A. Castellanos-Gomez et al. Nat. Nanotechnol. (2018)







T. Machida et al. Nat. Commun. (2018)

### van der Waals Heterostructures

#### Effect of hBN on Electrical Transport of Graphene









J. Xue et al. Nat. Mater. (2011)



Room-temperature mobility > 140,000 cm<sup>2</sup>/Vs

L. Wang et al. Science (2014)



40,000 cm<sup>2</sup>/V·s at 300K

Graphene
BN

A SIO

C. Dean et al. Nat. Nanotech. (2010)

### **Advantages of van der Waals Heterostructures**

#### 1. Ultrathin devices for flexible & transparent electronics



VS.

2. Ultrasharp heterointerface

G.H. Lee et al. ACS Nano (2013)



3. Arbitrary stacking





<u>G.H. Lee</u> et al. Nat. Nanotechno. (2015)





J. P et al. Nature (2017)

# **Advantages of van der Waals Heterostructures**

### 4. Band engineering



### 5. Strong light-matter interaction



L. Britnell et al. Science (2013)

60

x10

Laser nower ut

G33 nm △ 514 nm O 488 nm

80

#### 6. Vertical confinement in 2D space (quantum well structure)



R. V. Gorvachev et al. Science (2012)



F. Withers et al., Nat. Mater. (2015)

# **Advantages of van der Waals Heterostructures**

#### 7. Interlayer interaction (interlayer exciton)



A. Kis et al. Nature (2018)

### 8. Periodic potential modulation / Novel symmetry material systems (Quasicrystal)



L. A. Ponomarenko et al. Science (2019)

Y.W. Son et al. Science (2018)

### **Issue in Stacking**

#### **Formation of bubbles**



S. Jeong et al. Nanoscale (2017)

# Various Types of vdW Heterostructure Devices

1. Vertical contact

2. Vertical transistors

### 3. Vertical diodes



- Versatile work-function tunable contact
- Less contamination
- Non-damaging interface between metal and 2D channel



- High-speed, low-power and flexible
- Tunneling vertical transistors



- Unique E-field controlled p-n diodes
- Anti-ambipolar behavior

# Various Types of vdW Heterostructure Devices

f

### а n or p type D Gate oxide b n type p type Gate oxide с Gate oxide

4. Light harvesters and detectors

- Gate-dependent photoresponse (tunable carrier density)
- Dynamic modulation of diode characteristics
- Rapid extraction of exciton

### 5. Light emitting devices



- Au Al<sub>2</sub>O<sub>3</sub> Mos GaN  $\phi$  Pt
- Vertical device structure
- Vertical current injection
- Quantum well structure

## **Heterostructure of Graphene/hBN**



#### Tunable Schottky barrier in graphene

#### Tuning the graphene work function by electric field

P. Kim et al. Nano. Lett. (2009)

#### Field-effect tunneling transistor



L. A. Ponomarenko et al. Science (2012)

### **Barristor**

#### **Graphene barristor**



#### **Tunable Schottky barrier**





#### □ Barristor = Barrier + transistor

Barristor is a device that controls the on-off ratio by changing the Schottky barrier of graphene and silicon via the applied gate voltage.

### Flexible and Transparent Heterostructure Devices



Number of Layers



ACS Nano 7, 7931-7936 (2013)

### Heterostructure Charge Trap Memory











**Nature Communications** 4, 1624-1628 (2013)

### **Heterostructure of TMD/TMD**

#### **Band engineering**



J. Wu et al. Appl. Phys. Lett (2013)



#### Band structure dependent on TMD thickness



F. Wang et al. Nano Lett. (2010)





H. S. J. van der Zant et al Chem. Soc. Rev. (2018)

### **Heterostructure of TMD/TMD**

### WSe, ۵ 0 0.0000000000 MoS Two unit cells

**Atomically PN junction** 



#### **PN Junction device**







(mA)

0.3 0.4 0.5

0.0  $V_{ds}(V)$ 

V<sub>ds</sub>(V)



- 1L-1L

- 2L-2L

- ML-ML (10-9 nm)

50

Photocurrent (mA/W)

-150<del>|\_\_\_\_</del> -10

Ó



10 20 30 1.9 2.1 2.3 2.5 1.5 1.7 Voltage/thickness (mV/nm) Photon energy (eV)

C.H. Lee, <u>G.H. Lee</u> et al. Nat. Nanotechno. (2014)

### **Heterostructure of Graphene/Graphene**

#### Twisted bilayer graphene

#### Graphene quasi-crystal



P Jarillo-Herrero et al. Nature. (2018)

L. A. Ponomarenko et al. Science (2019)

Y.W. Son et al. Science (2018)



### **Excitons and Excitonic Devices**

### **Interlayer exciton**

Interlayer exciton		
Charge	Neutral Charge	
Transport mechanism	Diffusion	
Control parameter	Exciton density	

#### Interlayer excitons in the vdW heterostructure



#### Excitonic transistor operation by electric field



A. Kis et al. Nature (2018)

# **Light Emitting Devices**

#### 60 +40 V -40 Spectral intensity (counts) 100 Current (nA) 40 200 nA 20 Unipolar, 200 nA here a substant of the second states and the 1.2 1.5 2.0 2.2 Energy (eV)

TMDC Light Emitter

• Atomically thin LEDs (pn junction by split gate) from WSe<sub>2</sub>, MoS<sub>2</sub>, WS<sub>2</sub> • EQE: ~ 0.2 % (limited by contact and thickness)

> A. Pospischil et al. Nature Nanotech. 9, 257 (2015) B. W. H. Baugher et al. Nature Nanotech. 9, 262 (2015)

J. S. Ross et al. Nature Nanotech. 9, 268 (2015)

#### van der Waals Light Emitter



- Atomically thin quantum well with van der Waals heterostructure
- Efficient electron and hole injection by tunneling through hBN
- Flexible and transparent light emission devices
- EQE: 2.0 ~ 8.4 % (at low T)

#### F. Withers et al. Nature Materials 14, 301 (2015)

### **Monolayer WSe<sub>2</sub> LETs with Tunable Schottky Barrier**



J. Kwon, C. H. Lee, <u>G. H. Lee</u> Advanced Materials (2020)

# **Multi-operation Modes of WSe<sub>2</sub> LETs**



J. Kwon, C. H. Lee, <u>G. H. Lee</u> Advanced Materials (2020)

# **Light Emitting Devices**



J. Hone. et al. Nano Lett. (2018)



### Light emission from graphene



High breakdown current

### **Multiple Quantum Well of TMDs**

Fabrication process of WO<sub>x</sub>/WSe<sub>2</sub>/WO<sub>x</sub>/WSe<sub>2</sub> by Layer-by-layer oxidation



TQWs

0 L 1.4

70

50

6

3

Intensity (norm.)

60

FWHM (meV)

Y. S. Kim<sup>†</sup>, S. Kang<sup>†</sup>, G. H. Lee<sup>\*</sup>, C. H. Lee<sup>\*</sup> Science Advances 7, eabd7921 (2021)

1.6

Energy (eV)

1.7

1.5

1.8

### **Twist Angle of Stacked 2D Layers**



#### Charge transfer at interface of stacked 2D layers

- Electrical properties are influenced by stacking angle?
- The stacked layers are coupled or decoupled?
- Can we modify interfacial properties and band structure with twist angle and stacking structure?

### **Band Offset at Heterointerface**



J.H. Kim, G.H. Lee Unpublished

Ec

- Ev

### **Hetero-structured Contacts with Low Resistance**



H. Yoon, G.H. Lee, S.C. Jun et al. NPG Asia Mater. (2019)

# **Moiré Crystals**

#### Moiré superlattice



#### Moiré potential trapped interlayer exciton



### Twist angle control in TMDs heterobilayers



J. Baek, <u>G.H. Lee</u> In preparation

- Interlayer excitons are laterally confined from the moiré potential
- Atomic reconstruction occurred in twisted TMDs heterobilayer by thermal annealing.

#### Superconductivity in magic angle graphene



- Moiré potential trapped charge carriers contribute to novel quantum physics in 2D materials.
- □ Twisted bilayer graphene shows superconducting behavior at specific angle ( $\theta = 1.1^\circ$ ).

## Type of van der Waals heterostructure

- 1.Heterostructure of Graphene-hBN / TMD-hBN
  - High mobility
  - No hysteresis
- 2. Heterostructure of Graphene-TMD-hBN
  - Tunable Schottky barrier
  - Fast charge transfer
  - Barristor / LET
- 3. Heterostructure of Graphene Graphene
  - Twisted bilayer graphene
  - Quasi crystal
- 4. Heterostructure of TMD-TMD
  - Band engineering
  - PN junction
  - Interlayer exciton
- 5. Heterostructure of various 2D material
  - 2D magnetic : spin
  - 2D ferroelectric : NC transistor









## Heterostructure of Graphene-hBN / TMD-hBN

#### 1-1. Heterostructure of Graphene-hBN

 $\mu_{hall}$  for 1L Gr on hBN = 25000 cm<sup>2</sup>/Vs  $\mu_{hall}$  for 2L Gr on hBN = 40000 cm<sup>2</sup>/Vs  $\mu_{hall}$  for 1L Gr on SiO2 = 2500 cm<sup>2</sup>/Vs



J. Hone et al. Nat. Nanotechnol (2010)

#### 1-2. Heterostructure of TMD-hBN



G.H. Lee, J. Hone et al Nat. Nanotech (2013)

### **Heterostructure of magnetic material**

2D magnetic material Crl3



X. Xu et al. Nat. Nanotechno. (2018)

#### Giant tunneling magnetoresistance in spin filter



X. Xu et al. Science (2018)

#### Spin tunnel field effect transistor



K.F. Mak et al. Nat. Electro. (2019)

### Heterostructure of ferroelectricity material

d

PFM amplitude (pm)

1,000

800

600

400

200

-8

DC bias (V)

### 2D ferroelectric material CulnP<sub>2</sub>S<sub>6</sub>





PFM phase (°)

180

-90

-180

8



vdW NC transistor has 28 mV dec<sup>-1</sup> subthreshold swing(SS) and can overcome theoretically thermionic limit of 60 mV dec<sup>-1</sup>

Z. Liu et al. Nat. Commun. (2019)

### **Negative differential resistance device**

**NDR device** 



#### Ternary inverter with three logical states



- NDR device using band engineering of vdW heterostructure
- NDR charactersistric can be attributed to change types of band alignment from type III to type II.
- Multi-value level can be demonstrated, as ternary inverter fabricated using NDR characteristics

### Light emitting transistor with tunable Schottky barrier



### Light emitting transistor with tunable Schottky barrier



J. Kwon, G.H. Lee In preparation

### Light emitting transistor with tunable Schottky barrier

#### **Multi-mode Operation**



J. Kwon, G.H. Lee In preparation

## **Excitonic Light Emitting Devices**



## **Interlayer exciton**

### Strong light-matter interaction of TMD



P. S. Toth et al. Appl. Mater. Today (2017)

### Interlayer excition generation



X. Xu et al. Nat. Nanotechno. (2018)

#### Possibility of interlayer excition



TMD	Binding energy	Life time
Conventional S/C	1~20meV	300ns
2D S/C	300~500meV	0.001~20ns
Vdw heterostructure	200~300meV	100ns

### **Interlayer exciton**

#### **Diffusion of Interlayer exciton**



P. Kim et al. Science (2019)

### **Interlayer trion**

Exciton Trion

**Exciton vs Trion** 

Interlayer trion   🍄 👌		
Charge	Positive Charge Negative Charge	
Transport mechanism	Drift (+Diffusion)	
Control parameter	Electric field	

### Diffusion of Interlayer trion



### **Photoswitching logic and memory**



#### Different operation depend on channel thickness



AND gate



#### Memory using floating gate



P. Zhou et al. Nat. Nanotechno (2019)

### **Flexible and Transparent Heterostructure Devices**





Number of Layers



<u>G.H. Lee</u> et al. ACS Nano 7, 7931–7936 (2013)

# **Light Emitting Devices based on 2D Materials**

#### Thermionic emission

Lateral p-n diode

**Tunnel device** 



M. Steiner et al. Nano Lett. (2013)





F. Withers et al. Nat. Mater. (2015)



J. Hone. et al. Nano Lett. (2018)

X. Xu. et al. Nat. Nanotechno. (2014)

R. Gorbachev et al. Nat. Commun. (2020)

### vdW Heterostructure Device Platform



G.H. Lee, X. Cui, Y.D. Kim Nat. Nanotechno. (2015)

## **High Stability and Low Contact Resistance**



#### Gate-tunable graphene electrodes



G.H. Lee, X. Cui, Y.D. Kim et al. Nat. Nanotechno. (2015)

200

80

## **Ultrahigh Mobility of MoS<sub>2</sub>**



Device platform for measurement of intrinsic electrical properties of 2D materials

G.H. Lee, X. Cui, Y.D. Kim et al. Nat. Nanotechno. (2015)

### **Heterostructures of p-type and n-type**







Tunable photovoltaic effect? Light-emitting? New band structure at the interface?

C. Lee, <u>G. H. Lee</u> et al. Nat. Nanotechno. (2014)

### **Ultra-thin p-n Junction Devices**



C. Lee, <u>G. H. Lee</u> et al. Nat. Nanotechno. (2014)